

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Docket No. 26281-11A

MORI, Yasuhiro

Serial No.: To be determined

Filing Date: Concurrently herewith

Title: Method for Surface Preparation of Solid Substances and Surface-Prepared Solid Substances

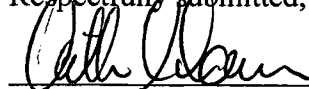
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INFORMATION DISCLOSURE STATEMENT

Pursuant to Sections 609 and 707.05(b) of the MPEP and 37 CFR 1.97-1.99, the attached form PTO-1449 lists documents that may be pertinent to the invention as claimed in the above-identified application. A copy of the international search report that cited two (2) of the referenced documents is attached to the copy of the international application being filed herewith.

This Information Disclosure Statement is being filed with the filing of the application and therefore, no fee is believed to be due. In the event that a fee is due, please charge Deposit Account No. 50-0447 to cover these fees. The citation of these documents should not be construed as a representation that a thorough search has been made, or that other, more pertinent material is not available.

Respectfully submitted,



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<b>INFORMATION DISCLOSURE CITATION FORM FOR PATENT APPLICATION (FORM PTO-1449) (Substitute)</b>			Docket No.: 26281-11A		Serial No.: <b>10/553563</b> to be assigned	
			Applicant: MORI, Yasuhiro			
			Filing Date: concurrently herewith		Group:	
<b>U.S. PATENTS</b>						
Initials	Patent Number	Issue Date	Name	Class	Sub-class	Filing date
	5,098,618	3.24.92	Zeletz			
<b>FOREIGN PATENT DOCUMENTS</b>						
Initials	Document Number	Date	Country	Name	Translation? Yes/No/n/a	
	<del>JP 2001-500552A</del>	<del>16.01.01</del>	<del>Japan</del>	<del>Minnesota Mining &amp; Manufacturing Co.</del>	<del>No</del>	
	<del>JP 4-59344 A</del>	<del>26.02.92</del>	<del>Japan</del>	<del>Toray Industries, Inc.</del>	<del>No</del>	
	<del>JP 05-068934</del>	<del>23.03.93</del>	<del>Japan</del>	<del>Japan Storage Battery Co. Ltd.</del>	<del>English Abstract</del>	
	<del>JP 10-067869</del>	<del>10.03.98</del>	<del>Japan</del>	<del>Nippon Paint Co. Ltd.</del>	<del>English Abstract</del>	
	<del>JP 08-109228</del>	<del>30.04.96</del>	<del>Japan</del>	<del>Kanazawa Hitoshi</del>	<del>English Abstract</del>	
	<del>JP 09-124810</del>	<del>13.05.97</del>	<del>Japan</del>	<del>KDK Corp.</del>	<del>English Abstract</del>	
	<del>JP 2000-272249</del>	<del>03.10.00</del>	<del>Japan</del>	<del>Teijin Ltd.</del>	<del>English Abstract</del>	
	<del>WO/98/11154</del>	<del>19.03.98</del>	<del>WIPO</del>	<del>Minnesota Mining &amp; Manufacturing Co.</del>	<del>Yes</del>	
	<del>DE 100 19 926 A1</del>	<del>31.10.01</del>	<del>Germany</del>	<del>Isimat GmbH</del>	<del>No</del>	
	<del>EP 0 594 171 A1</del>	<del>27.04.94</del>	<del>Europe</del>	<del>Siebdruckmaschinen Flachglas</del>	<del>No</del>	
	<del>EP 1 148 036 A1</del>	<del>24.10.01</del>	<del>Europe</del>	<del>Aktiengesellschaft Isimat GmbH</del>	<del>No</del>	
	<del>DE 100 18 223 A1</del>	<del>19.04.01</del>	<del>Germany</del>	<del>Siebdruckmaschinen Nanogate GmbH</del>	<del>Yes</del>	
	<del>DE 199 05 697 A1</del>	<del>17.08.00</del>	<del>Germany</del>	<del>Gobel, Roland</del>	<del>Yes</del>	
	<del>DD 256 151 A1</del>	<del>27.04.88</del>	<del>Germany</del>	<del>Friedrich-Schiller-Universitat Jena</del>	<del>Yes</del>	
<b>OTHER DOCUMENTS (Title, Author, Date, Pages, Etc., if known)</b>						
Examiner's Signature: /Margaret Moore/ (09/02/2008)				Date Considered:		
Initial if reference was considered, whether or not citation is in conformance with MPEP. Mark through citation if not considered. Include a copy of this citation form with your next correspondence to the Applicant(s).						